MAY 18 2005 W Actorney's Docket No.: 042390P11354 Confirmation No.: 8234

**Patent** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	)
Liang, Ted et al.	)
U.S. Serial No: 09/895,511	) Examiner: Zervigon, Rudy
Filed: June 29, 2001	) Art Unit: 1763
For: APPARATUS FOR ELECTRON BEAM-INDUCED CHEMICAL ETCHING	) ) _)
Mail Stop RCE Commissioner for Patents P. O. 1450 Alexandria, VA 22313-1450	
DDELD (INLAD	OV ANGENIEN GENEE
PRELIMINAR	Y AMENDMENT
Dear Sir:	
Applicants respectfully request th	at this Preliminary Amendment be entered
prior to examination of the above-identif	ied patent application.
FIRST CLASS CERTIFICATE O	F MAILING
I hereby certify that this correspondence is being deposited v sufficient postage in an envelope addressed to Mail Stop RC VA 22313-1450.	E, Commissioner for Patents, P.O. Box 1450, Alexandria,
onMay 16, 2005	
Date of Deposit	
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Signature	Date

Attorney Docket: 042390P11354